



PATENT

## UNITED STATES PATENT AND TRADEMARK OFFICE

Application

Michael J. PELLIN, et al.

Serial No.:

10/799,181

Application:

ATOMIC LAYER DEPOSITION FOR HIGH TEMPERATURE  
SUPERCONDUCTORS MATERIAL SYNTHESIS

Art Unit:

2812

Filing Date:

March 12, 2004

Atty. Docket:

0003/01288

CERTIFICATE OF MAILING: I hereby certify that this correspondence is being deposited per 37 C.F.R. 1.8 with the United States Postal service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 3, 2006 (Date of Deposit)

Marilynn G. Oleck

Name of Representative

Signature

11/3/06  
Date of Signature

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

20 North Wacker Dr.  
Chicago, IL 60606  
312-621-1330

**STATUS INQUIRY**

Sir/Madam:

This is an official Status Inquiry request for the above-identified application.

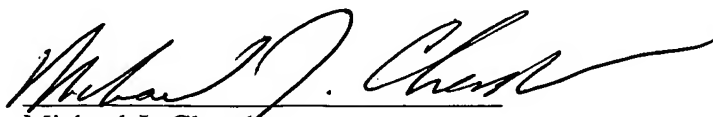
More than 30 months has passed since the filing of this Patent Application on March 12, 2004. A return postcard stamped by the USPTO having serial number 10/799,181 has been received. Attorney check #.3600 in the amount of \$425.00 which accompanied the filing has been cashed.

Enclosed please find photocopies of the following: a June 1, 2004 filing receipt, USPTO stamped return postcard, the cashed check, and the Recordation of Assignment. No further communication has been received from the Patent and Trademark Office indicating action on this application.

Kindly advise the undersigned of the present status of this application.

Respectfully submitted,

Dated: November 3, 2006

  
Michael J. Cherskov  
Reg: No.: 33,664  
Attorney for applicants



## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/799,181	03/12/2004	2812	385	0003/01288	7	20	2

CONFIRMATION NO. 8160

27197

CHERSKOV & FLAYNIK  
THE CIVIC OPERA BUILDING  
20 NORTH WACKER DRIVE, SUITE 1447  
CHICAGO, IL 60606

## FILING RECEIPT



\*OC000000012822344\*

Date Mailed: 06/01/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Michael J. Pellin, Naperville, IL;  
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Jeffrey W. Elam, Downers Grove, IL;

## Domestic Priority data as claimed by applicant

This appln claims benefit of 60/454,160 03/12/2003

## Foreign Applications

If Required, Foreign Filing License Granted: 05/28/2004

Projected Publication Date: 09/16/2004

Non-Publication Request: No

Early Publication Request: No

\*\* SMALL ENTITY \*\*

## Title

Atomic layer deposition for high temperature superconductor material synthesis

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Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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On the date stamped hereon, the United States Patent and Trademark Office acknowledges receipt of an application, drawings, Utility Transmittal, a recordation sheet, a fee transmittal, Assignment, a Declaration, a check, and a return-receipt postcard.

Re: Pellin et al.

Title: ATOMIC LAYER DEPOSITION FOR HIGH TEMPERATURE  
SUPERCONDUCTOR MATERIAL SYNTHESIS

Atty. Dkt.: 0003/01288

The aforementioned was mailed on Friday, March 12, 2004 via  
Express Mail #ER605288065US.



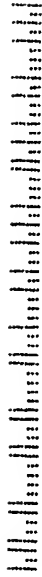
22141 U.S. PTO  
10/799181



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**SUITE 1447**  
**90 N. WACKER DRIVE**  
**CHICAGO, IL 60606**



030



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DATE March 12, 2004 2-50-710

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UNITED STATES PATENT AND TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND  
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE

APRIL 25, 2005

PTAS



\*102875291A\*

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RECORDATION DATE: 04/22/2004

REEL/FRAME: 015937/0487  
NUMBER OF PAGES: 2

BRIEF: ASSIGNMENT OF ASSIGNOR'S INTEREST (SEE DOCUMENT FOR DETAILS).

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DOC DATE: 03/12/2004

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SERIAL NUMBER: 10799181

FILING DATE: 03/12/2004

PATENT NUMBER:

ISSUE DATE:

TITLE: ATOMIC LAYER DEPOSITION FOR HIGH TEMPERATURE SUPERCONDUCTOR  
MATERIAL SYNTHESIS

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